

| | | | |
|-----------------------------------|---------------------------------------|----------------------------------------------------------|-------------|
| Notice of References Cited | Application/Control No. 10/633,982 | Applicant(s)/Patent Under Reexamination LIN ET AL. | |
| | Examiner Ly D. Pham | Art Unit 2827 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--------------------------------------------------|-----------------|------------------|----------------|
| * | A | US-2004/0095819 A1 | 05-2004 | Joachim et al. | 365/201 |
| * | B | US-2003/0095457 A1 | 05-2003 | Jeon et al. | 365/205 |
| * | C | US-2004/0141353 A1 | 07-2004 | Madan, Sudhir K. | 365/145 |
| * | D | US-6,310,797 B1 | 10-2001 | Muneno, Hidehiro | 365/145 |
| | E | US- | | | |
| | F | US- | | | |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--------------------------------------------------|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|-------------------------------------------------------------------------------------------|
| | U | |
| | V | |
| | W | |
| | X | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.